

Docket No. 213672US2

IN RE APPLICATION OF: Kenji YAMAGUCHI, et al.

SERIAL NO: 09/955,080

FILED: September 19, 2001

FOR: SEMICONDUCTOR DEVICE EVALUATION METHOD AND APPARATUS, SEMICONDUCTOR DEVICE MANUFACTURING CONTROL METHOD, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND RECORDING MEDIUM

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
 Additional documents filed herewith: Information Disclosure Statement (IDS)
PTO-1449 form; Cited Reference (1)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	22	MINUS	20	2	x \$18 =	\$36.00
INDEPENDENT	5	MINUS	4	1	x \$86 =	\$86.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$290 =	\$0.00
						TOTAL OF ABOVE CALCULATIONS \$122.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL \$122.00

A check in the amount of \$0.00 is attached.
 Credit card payment form is attached to cover the fees in the amount of \$122.00
 Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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2814

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

KENJI YAMAGUCHI, ET AL.

: EXAMINER: PIZARRO CRESPO,
MARCOS D

SERIAL NO: 09/955,080

:

FILED: SEPTEMBER 19, 2001

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE
EVALUATION METHOD AND
APPARATUS, SEMICONDUCTOR
DEVICE MANUFACTURING CONTROL
METHOD, SEMICONDUCTOR DEVICE
MANUFACTURING METHOD, AND
RECORDING MEDIUM

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated June 25, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

09/24/2004 EFLORES 00000072 09955080

01 FC:1201
02 FC:1202

86.00 OP
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